



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KAWARAYA, Masahide, et al.**

Group Art Unit: **2813**

Serial No.: **10/530,475**

Examiner: **RODGERS, Colleen E.**

Filed: **April 6, 2005**

P.T.O. Confirmation No.: **4981**

FOR: **PROCESS FOR FORMING SEMICONDUCTOR FILM AND USE OF SEMICONDUCTOR FILM**

RESPONSE UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 8, 2008

Sir:

In response to the Office Action dated **February 13, 2008**, the period for response extended to **July 13, 2008**, by a Petition for a two-month Extension of Time, the following remarks are respectfully submitted:

Remarks/Arguments begin on page 2 of this paper.